



AF (JFW)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Daniel R. Caldwell, et al. Docket No: TI-36721
Serial No: 10/706,762 Conf. No: 7834
Examiner: Dung V. Nguyen Art Unit: 3723
Filed: 11/10/2003
For: CHEMICAL MECHANICAL POLISHING SLURRY PUMP MONITORING SYSTEM AND METHOD

**NOTICE OF APPEAL FROM THE PRIMARY EXAMINER
TO THE BOARD OF APPEALS**

Mail Stop AF
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 6-24-05.


Ann Trent

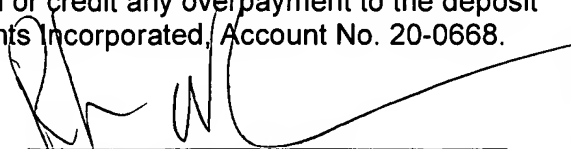
Dear Sir:

Applicants hereby appeal to the Board of Appeals from the decision of the Primary Examiner mailed March 25, 2005, finally rejecting Claims 1-20.

The item(s) checked below are appropriate:

1. ☐ An extension of time to respond to the final rejection
☐ was granted on _____.
☐ is requested for ____ month.
2. ☒ A timely response to the final rejection has been filed.
3. ☒ Fee \$500.00:
☐ Not required (Fee paid in prior appeal)
☒ The Commissioner of Patents is hereby authorized to charge any fees which may be required or credit any overpayment to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.

Texas Instruments Incorporated
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